

Notice of References Cited

Application/Control No.

09/804,158

Applicant(s)/Patent Under
Reexamination
KAWADA ET AL.

Examiner

Kripa Sagar

Art Unit

1756

Page 1 of 1

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NON-PATENT DOCUMENTS

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	V	"Long-throw, low pressure sputtering technology for very large-scale integrated devices", N.Motegi et al., J.Vac.Sci.Technol., B v13,(1995), pp1906-1909.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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